



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor application of: Dalton et al.

Attorney Docket No.:
NOVLP082/NVLS-2893

Application No.: 10/772,109

Examiner: Jarrett Stark

Filed: February 3, 2004

Group: 2823

Title: USE OF METALLOCENES TO INHIBIT
COPPER OXIDATION DURING
SEMICONDUCTOR PROCESSING

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on August 28, 2007 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: _____

Joyce L. Ferreira

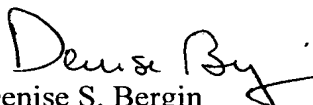
**SEPARATE LETTER TO EXAMINER
REQUESTING DRAWING APPROVAL**

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Due to informalities in the original drawings enclosed are substitute (formal) drawings for the above-identified patent application. If the Draftsman has any question concerning these drawings, he or she is respectfully requested to contact the undersigned.

Respectfully submitted,
BEYER WEAVER LLP


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